

Special Topics on Basic EECS I Design Technology Co-Optimization

Lecture 7

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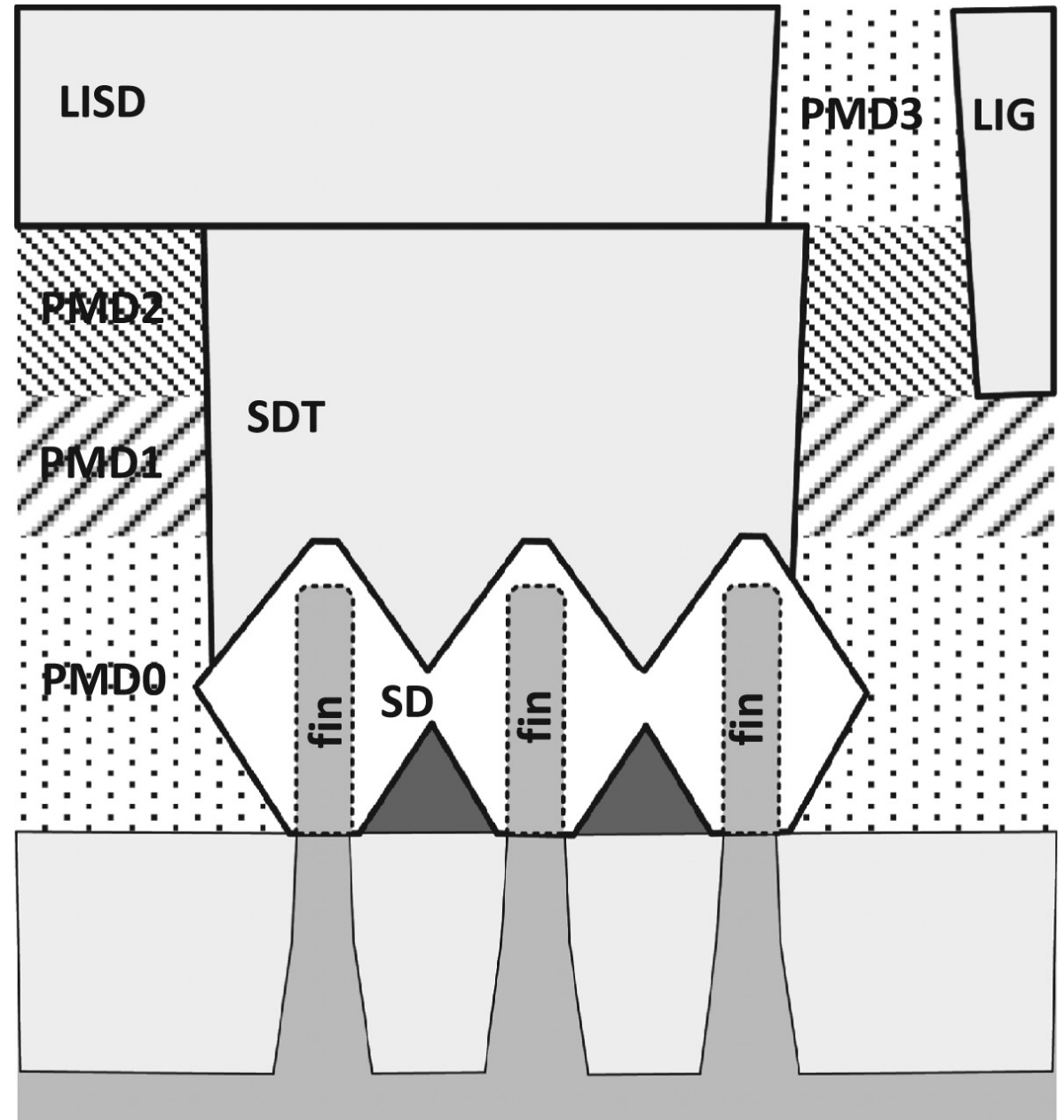
Department of Electrical Engineering and Computer Science

Gwangju Institute of Science and Technology (GIST)

L7

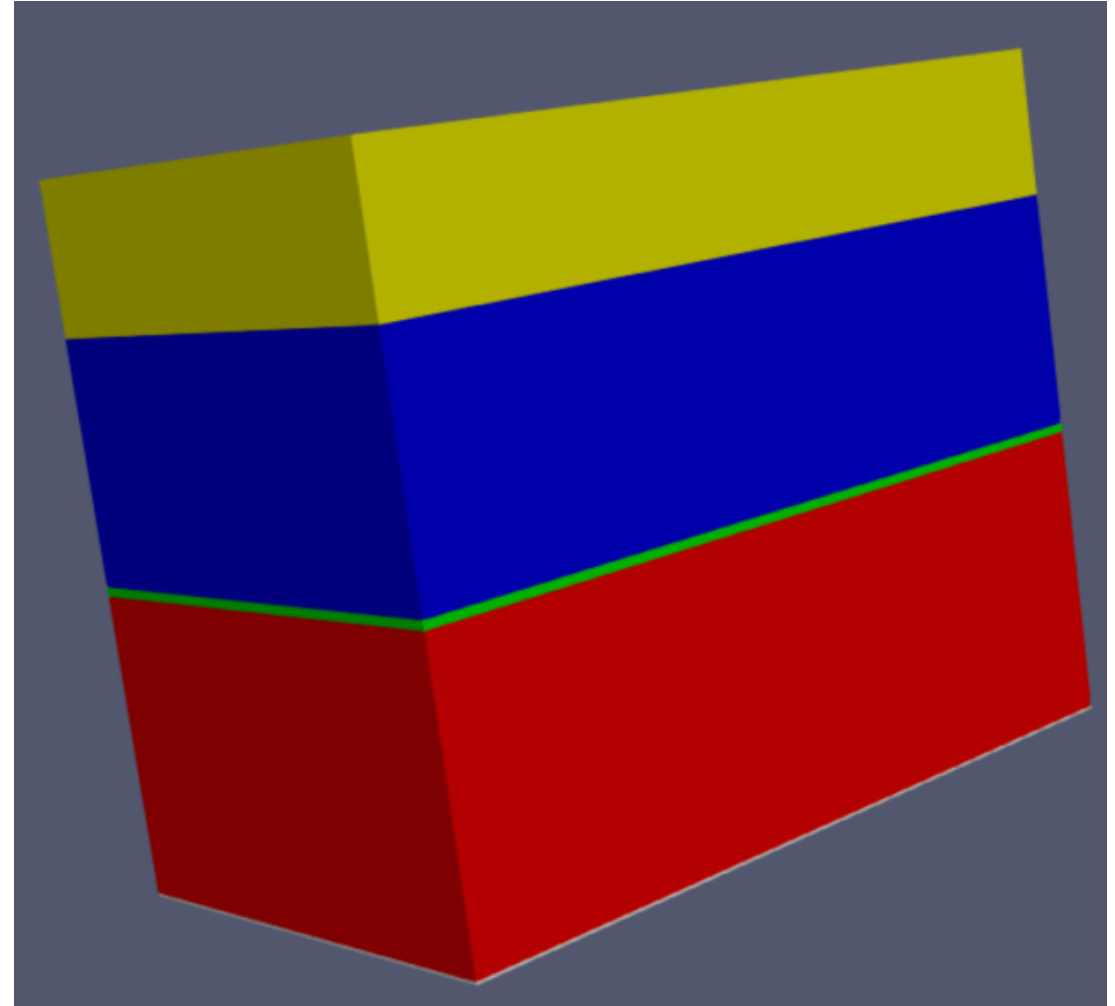
Fin in ASAP7

- Fin height = 32 nm. Fin width = 7 nm. (It's 6.5 nm actually, but we will just use 7 nm.)
 - A 32-nm-tall fin is a little short. (In reality, ~50 nm?)
 - STI depth = 30 nm
- It seems that ASAP7 does not improve the fin shape.
 - Anyway, just follow it.



Pad oxide & hard mask

- A 100-nm-thick substrate
- Pad oxide = 3 nm
 - Actually, it is not deposited.
 - Thermal oxidation
- Hard mask = 80 nm
 - Silicon nitride
- Mandrel = 50 nm
 - Amorphous silicon



We want to have a fin pitch of 27 nm.

- Self-aligned quadruple patterning (SAQP)
 - In reality, it is used.
- For simplicity, self-aligned double patterning (SADP)
 - Draw lines with a pitch of 54 nm (= width of 24 nm + spacing of 34 nm).
 - Define a mask.
 - Multiple rectangles
 - x_0 , y_0 , x_1 , and y_1
(Two diagonal vertices)
 - These rectangles are masked.

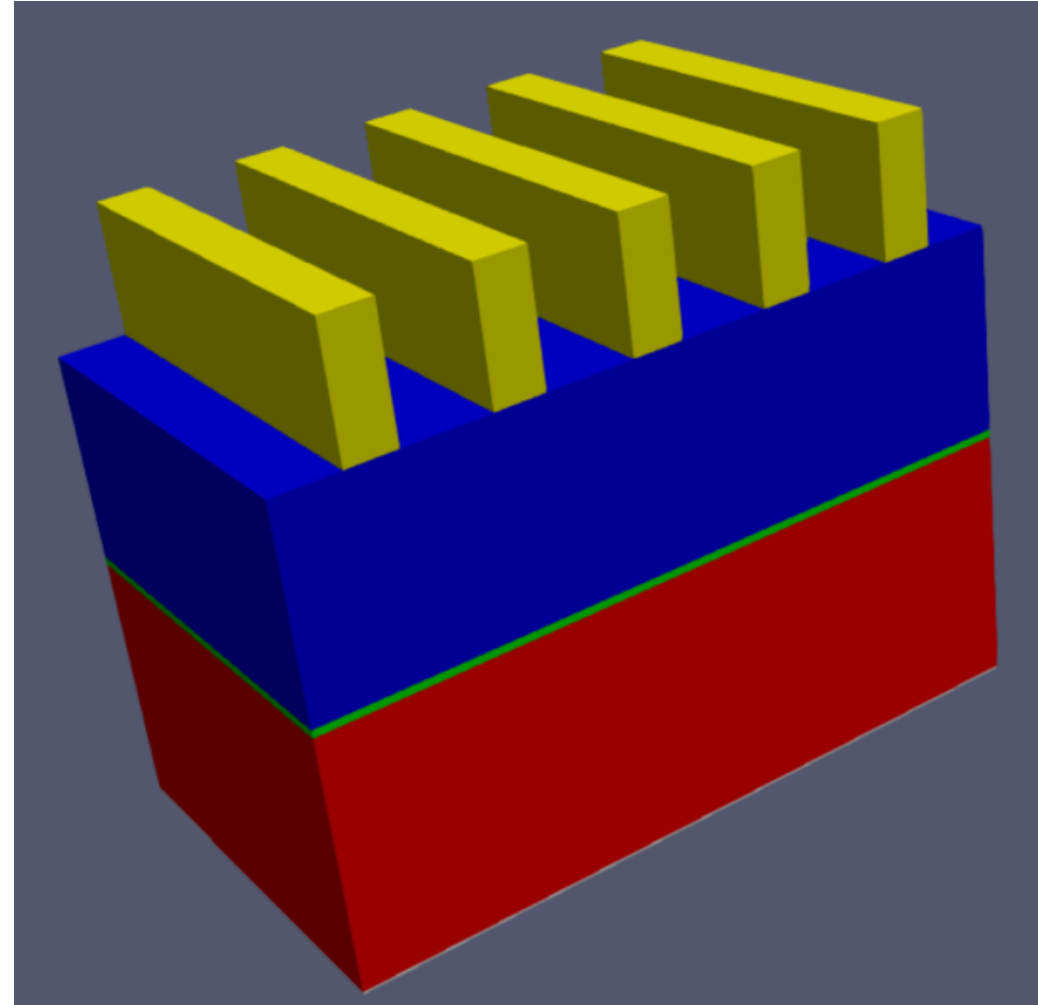
```
mask (name="mask_fin", lx=162, ly=288) {  
    rectangle (x0=0, y0= 26, x1=162, y1= 46)  
    rectangle (x0=0, y0= 80, x1=162, y1=100)  
    rectangle (x0=0, y0=134, x1=162, y1=154)  
    rectangle (x0=0, y0=188, x1=162, y1=208)  
    rectangle (x0=0, y0=242, x1=162, y1=262)  
}
```

We want to have a fin pitch of 27 nm.

- Etch using the mask.

```
etch (mask="mask_fin", thickness=50)
```

- Anisotropic etching
(Still under development!)

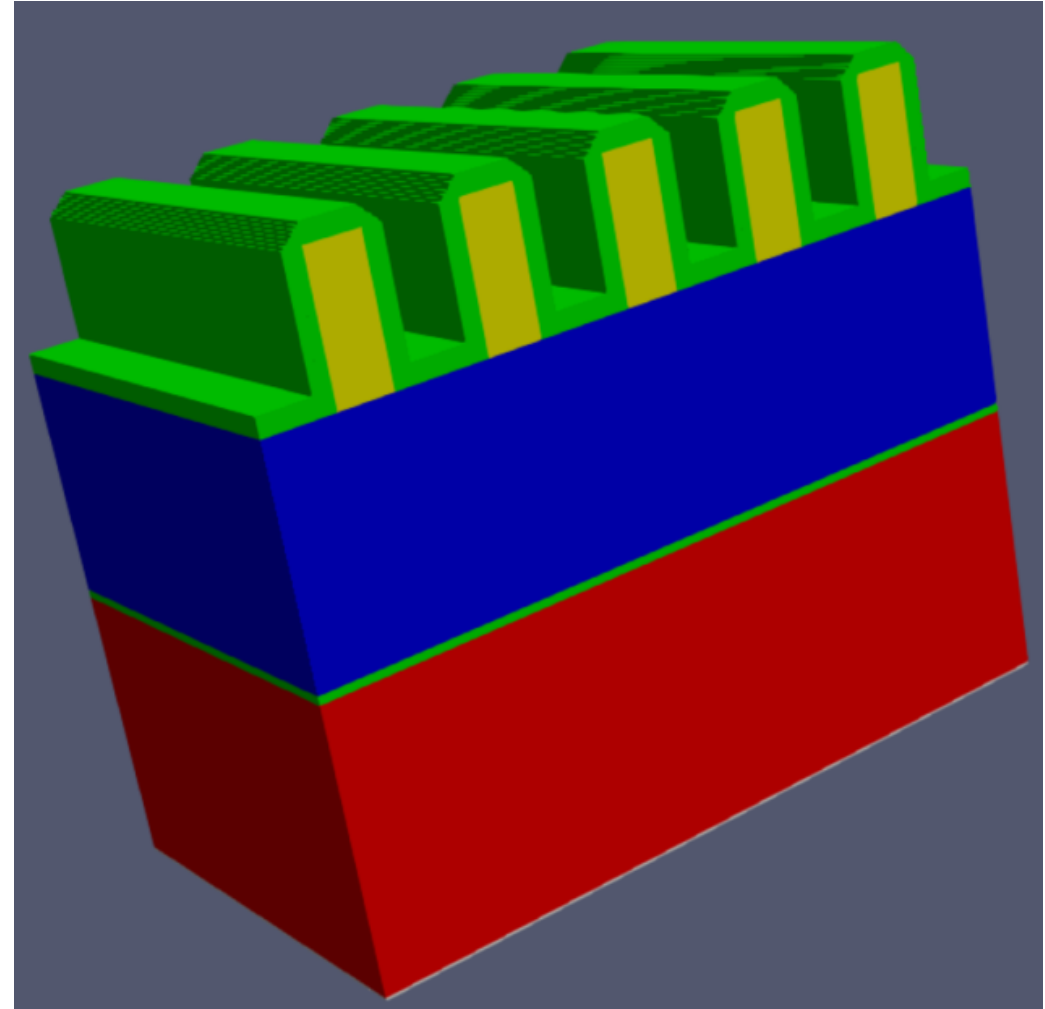


Isotropic deposition

- 7-nm-thick SiO_2

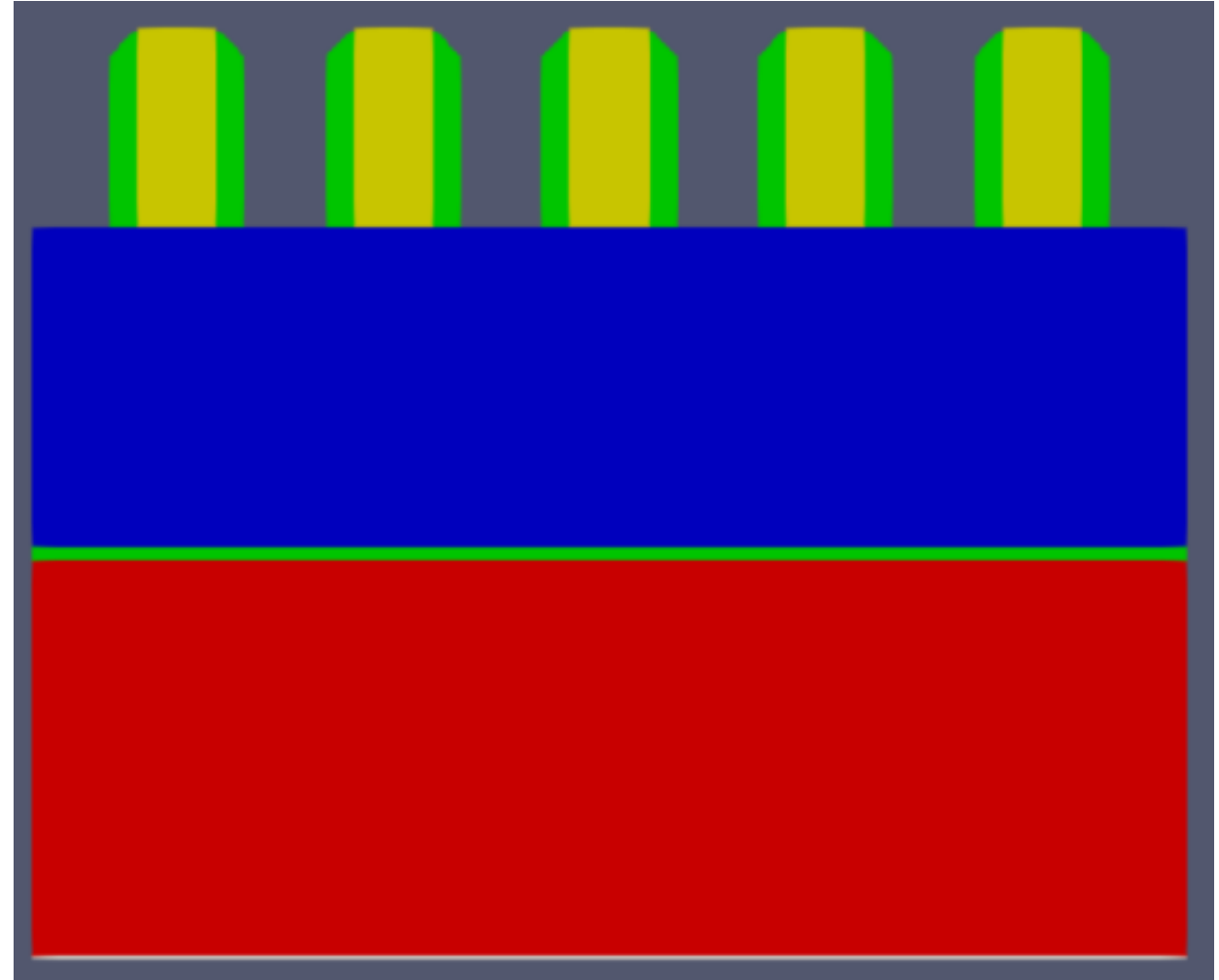
depo (region="SiO2", thickness=7)

– (Its shape is not perfect.)



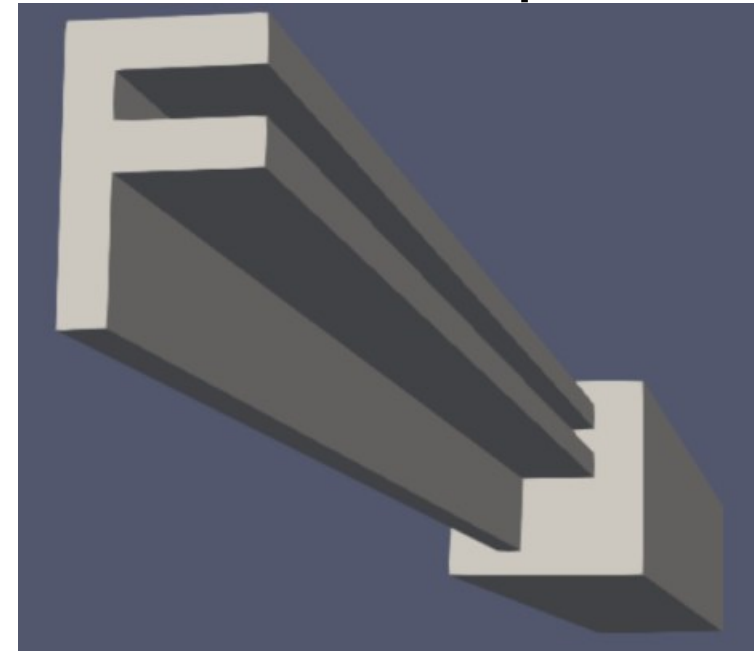
Anisotropic etching, again

- 7 nm, etch (thickness=7)
 - Remaining sidewall
 - Its thickness? 7 nm.
- Etching only a-Si
 - We have the fin pattern.



Homework#7

- Due: 08:00 on Sep. 29
- Submit a report through the GIST LMS system.
 - By using the AngstromCraft code, draw an alphabet letter, whichever you prefer.
 - Your report must show the final structure and the input file.
 - (The figure shows my F.)



Thank you!